

Maglev 200™ Magnetic Levitation Haptic Interface

A breakthrough in haptics

Maglev Haptics™ is a revolutionary new technology for high-fidelity interaction with virtual or remote environments through the sense of touch. The user grasps a handle rigidly attached to a flotor levitated by strong magnetic fields. The handle can be freely moved in six degrees of freedom through a comfortable motion range, sending position and orientation information to the user's application. The application, in turn, outputs forces and torques to the handle.

Available haptic-interaction devices are small back-driven robot arms, which include mechanical elements that can limit fidelity due to friction, backlash, link bending, and motor cogging. These drawbacks are eliminated with Maglev Haptics™.

Butterfly Haptic's Maglev 200 system is the first commercial haptic system to employ the principles of Lorentz levitation to give the user an extremely high-fidelity haptic experience. For maximum performance the system includes its own high-performance embedded controller, off-loading burdensome computations from the user's host computer.

The hardware incorporates several highly innovative design features and advanced manufacturing technologies to provide high quality and reliable operation at a reasonable cost.



Innovative features

- Six degrees of freedom*
- Single moving part*
- Zero static friction*
- Zero mechanical backlash*
- High bandwidths*
- High position resolution*
- Wide stiffness range*
- Mechanical simplicity*

Advanced applications

- Medical/dental training*
- Microsurgery*
- Data set visualization*
- Character animation*
- Effort-reflected flight*
- Computer aided design*
- Remote robot control*
- Micro/nano manipulation*

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The Butterfly Haptics Maglev 200 system includes the Model 201 device, Model 202 controller, cables, detachable mouse-like handle, desktop mounting kit, manuals, and client-side software (API, graphical monitor, and demos).



Top View



Bottom View

Model 201 Device



Front View



Back View

Model 202 Controller

Design features

Degrees of Freedom	6, upgradable to 7
Amplifiers	Low Noise Linear
Handle	Interchangeable
Included Handle	Mouse-Like
Handle Buttons	2
Device Pose	Adjustable 0-90 deg.
Device Mass (Model 201)	18 Kg
Device Diameter	0.40 m sphere
Controller Mass (Model 202)	14.5 Kg
Controller Dimensions	0.20 x 0.45 x 0.53 m
Power Requirements	115V/6A, 230V/3A

Performance characteristics

Translational Workspace	24 mm Dia.Sphere
Rotational Range	+/-8 deg (see note 1)
Position Resolution (1 sigma)...	< 2.0 microns
Angular Resolution (1 sigma)...	3.6 arcsec
Position Bandwidth (-3dB)	140 Hz
Force Bandwidth at Manipulandum.	>2000 Hz
Peak Force (Z axis)	40 N
Force Resolution	20 mN
Peak Torque (Z axis)	3.6 Nm
Maximum Translational Stiffness	50 N/mm
Minimum Translational Stiffness	0.002 N/mm
Maximum Rotational Stiffness ...	5.1 Nm/deg
Minimum Rotational Stiffness ...	0.01 Nm/deg
Backdrive Static Friction	0.0 N
Mechanical Backlash	0.0 microns
Perceived Mass (Flotor)	616 g
Maximum Servo Rate	4000 Hz
Levitation Power	4.5 W
Stray Field at Handle	0.001T

Software

Embedded RT Operating System ...	QNX 6.3
Communication	100 Mb/s Ethernet
User Interface (C/C++ Language).	Structured API
Testing and Debugging Facility ..	Graphical Monitor
Host OS Compatibility	Linux, Windows
Haptic API Compatibility	CHAI 3D, MATLAB®

Note 1: Rotational range is reduced near the limits of the translational workspace.